



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6339**  
Kazufumi SATO et al. : Attorney Docket No. 2003\_1687  
Serial No. 10/716,632 : Group Art Unit 1752  
Filed November 20, 2003 : Examiner John S. Y. Chu  
POSITIVE-WORKING PHOTORESIST  
COMBINATION : **Mail Stop: Amendment**

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**RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 19, 2005, please amend the present application as follows: